

**Amplifier, Power, 18W
7.5-10.5 GHz**

MAAP-000079-PED000

Rev—
Preliminary Datasheet

Features

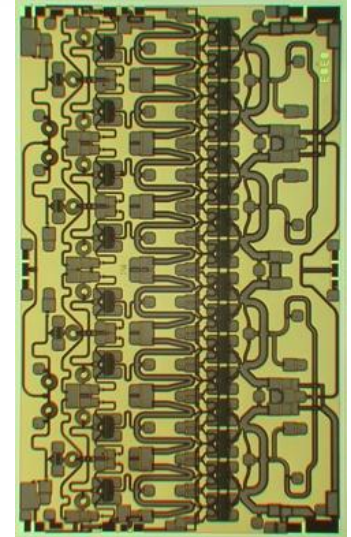
- ◆ 18 Watt Saturated Output Power Level
- ◆ Eutectically Mounted to Heat Spreader
 - ◆ Next level integration is a Silver Epoxy-Based Process
- ◆ Variable Drain Voltage (8-10V) Operation
- ◆ MSAG™ Process

Description

The MAAP-000079-PED000 is a 3 stage 18W power amplifier with on-chip bias networks, eutectically mounted on a 10-mil thick Copper Molybdenum (CuMo) pedestal. This product is fully matched to 50 ohms on both the input and output. It can be used as a power amplifier stage or as a driver stage in high power applications.

Fabricated using M/A-COM's repeatable, high performance and highly reliable GaAs Multifunction Self-Aligned Gate (MSAG™) Process, each device is 100% RF tested at the die-on-pedestal assembly level to ensure performance compliance.

M/A-COM's MSAG™ process features robust silicon-like manufacturing processes, planar processing of ion implanted transistors, multiple implant capability enabling power, low-noise, switch and digital FETs on a single chip, and polyimide scratch protection for ease of use with automated manufacturing processes. The use of refractory metals and the absence of platinum in the gate metal formulation prevents hydrogen poisoning when employed in hermetic packaging.



Primary Applications

- ◆ SatCom
- ◆ Commercial Avionics
- ◆ Radar

Also Available in:

Description	Ceramic Package	Sample Board (Die)	Sample Board (Pkg)	Mechanical Sample (Die)
Part Number	MAAP-000079-PKG001	MAAP-000079-SMB004	MAAP-000079-SMB001	MAAP-000079-MCH000

Electrical Characteristics: $T_B = 40^\circ C^1$, $Z_0 = 50 \Omega$, $V_{DD} = 10V$, $I_{DQ} = 4A^2$, $P_{in} = 18 \text{ dBm}$, $R_g = 20 \Omega$

Parameter	Symbol	Typical	Units
Bandwidth	f	7.5-10.5	GHz
Output Power	P_{OUT}	42.5	dBm
Output Power, 8-10 GHz	P_{OUT}	43	dBm
1-dB Compression Point	P1dB	42	dBm
Small Signal Gain	G	29	dB
Power Added Efficiency	PAE	30	%
Input VSWR	VSWR	2.5:1	
Output VSWR	VSWR	2.5:1	
Gate Current	I_{GG}	50	mA
Drain Current, under RF Drive	I_{DD}	6	A
Output Third Order Intercept	TOI	48	dBm
Output Third Order Intermod, Pout = 39 dBm (DCL)	IM3	18.5	dBc

1. T_B = MMIC Base Temperature
2. Adjust V_{GG} between -2.6 and -1.5V to achieve specified I_{DQ} .

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Maximum Ratings³

Parameter	Symbol	Absolute Maximum	Units
Input Power	P_{IN}	23	dBm
Drain Supply Voltage	V_{DD}	+12.0	V
Gate Supply Voltage	V_{GG}	-3.0	V
Quiescent Drain Current (No RF)	I_{DQ}	6.5	A
Quiescent DC Power Dissipated (No RF)	P_{DISS}	65	W
Junction Temperature	T_J	170	°C
Storage Temperature	T_{STG}	-55 to +150	°C

3. Operation beyond these limits may result in permanent damage to the part.

Recommended Operating Conditions⁴

Characteristic	Symbol	Min	Typ	Max	Unit
Drain Voltage	V_{DD}	4.0	10.0	10.0	V
Gate Voltage	V_{GG}	-2.6	-2.2	-1.5	V
Input Power	P_{IN}		18.0	21.0	dBm
Thermal Resistance	Θ_{JC}		3.0		°C/W
MMIC Base Temperature	T_B			Note 5	°C

4. Operation outside of these ranges may reduce product reliability.

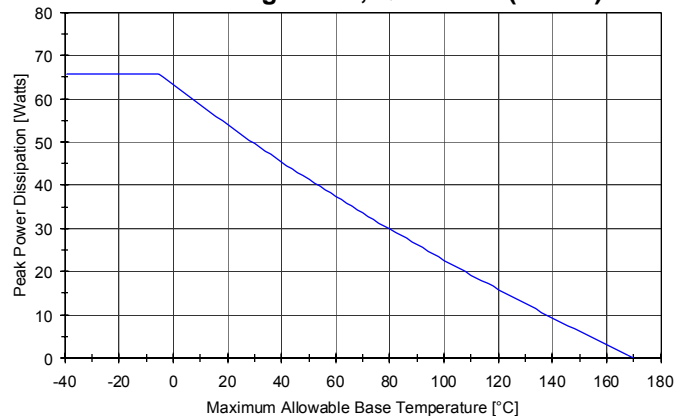
5. MMIC Base Temperature = 170°C — $\Theta_{JC} * V_{DD} * I_{DQ}$

Operating Instructions

This device is static sensitive. Please handle with care. To operate the device, follow these steps.

1. Apply $V_{GG} = -2.7$ V, $V_{DD} = 0$ V.
2. Ramp V_{DD} to desired voltage, typically 10.0 V.
3. Adjust V_{GG} to set I_{DQ} , (approximately @ -2.2 V).
4. Set RF input.
5. Power down sequence in reverse. Turn V_{GG} off last.

Power Derating Curve, Quiescent (No RF)



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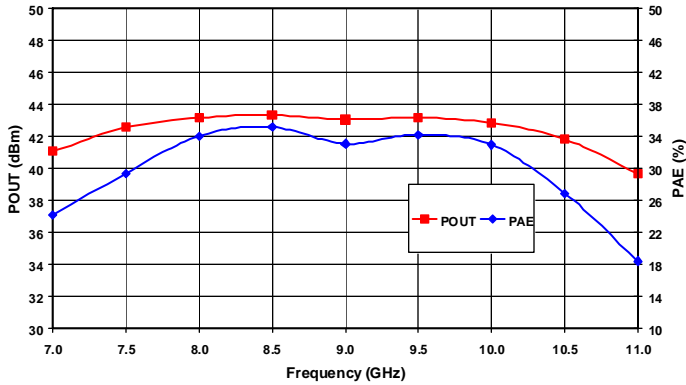


Figure 1. Output Power and Power Added Efficiency vs. Frequency at $V_{DD} = 10V$ and $P_{in} = 18 dBm$

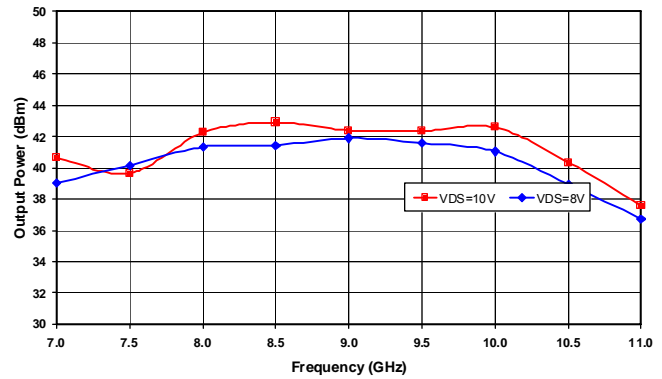


Figure 2. 1dB Compression Point vs. Drain Voltage

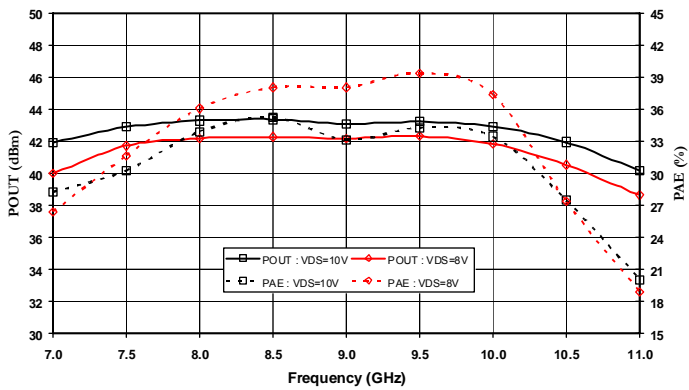


Figure 3. Saturated Output Power and Power Added Efficiency vs. Frequency and Drain Voltage

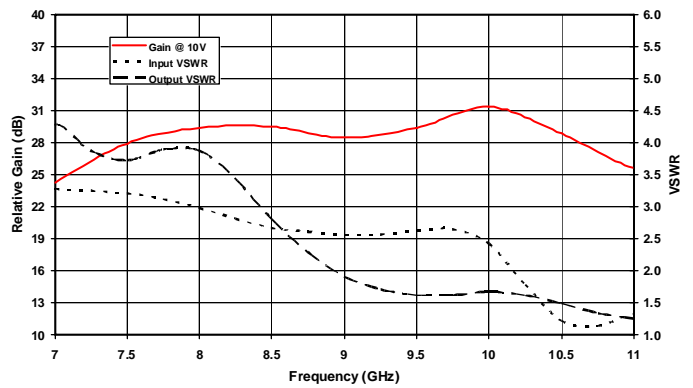


Figure 4. Small Signal Gain and Input and Output VSWR vs. Frequency.

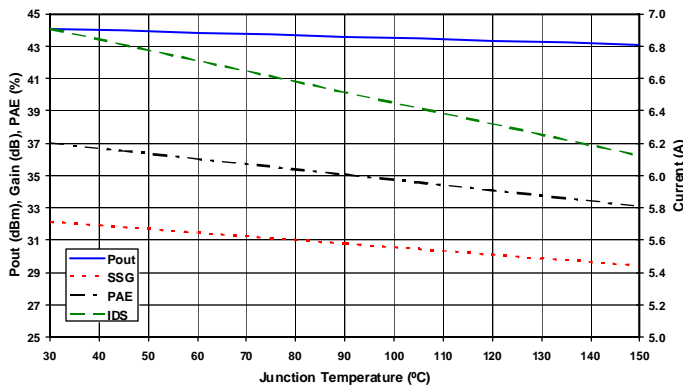


Figure 5. Output Power, Power Added Efficiency, and Drain Current vs. Junction Temperature at $V_{DD}=10V$, $f=9GHz$, and $P_{in}=18dBm$.

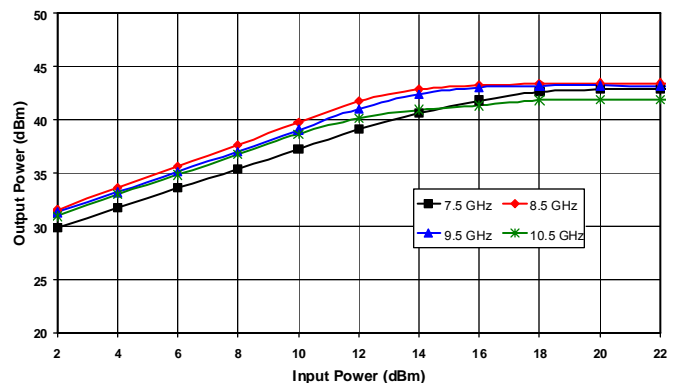


Figure 6. Output Power vs. Input Power at $V_{DD} = 10V$

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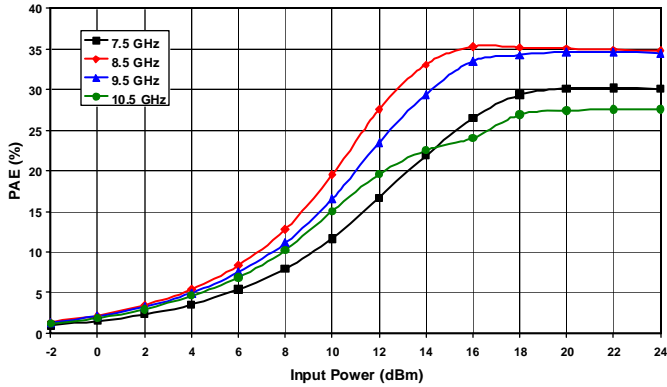


Fig 7. Power Added Efficiency vs. Input Power at $V_D=10V$.

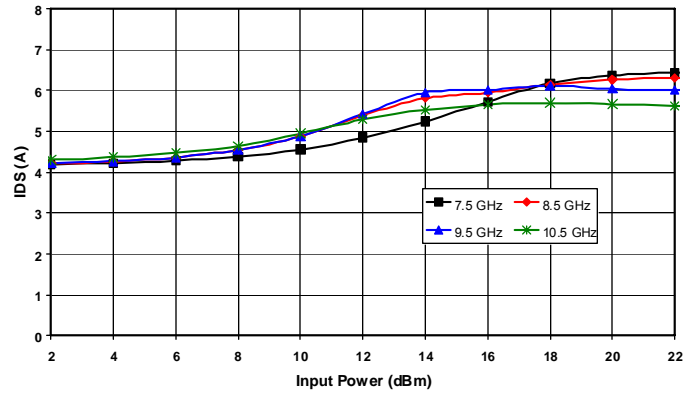


Figure 8. Drain Current vs. Input Power at $V_{D0} = 10V$

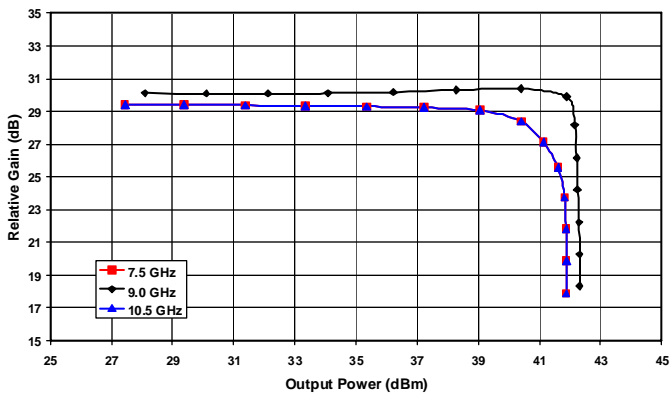


Figure 9. Relative Gain vs. Output Power by Frequency at $V_D=8V$ and 25% IDSS

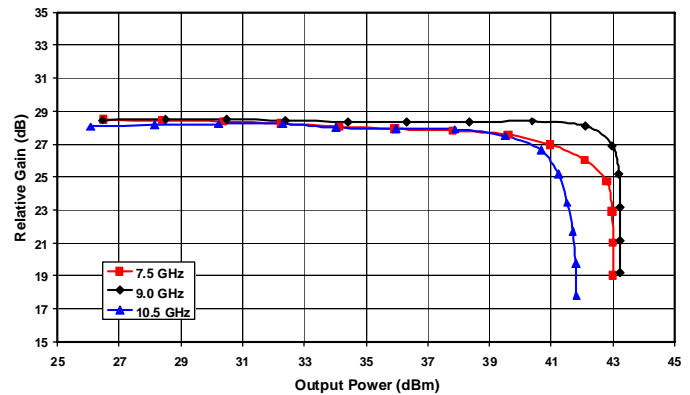


Figure 10. Relative Gain vs. Output Power by Frequency at $V_D=10V$ and 25% IDSS

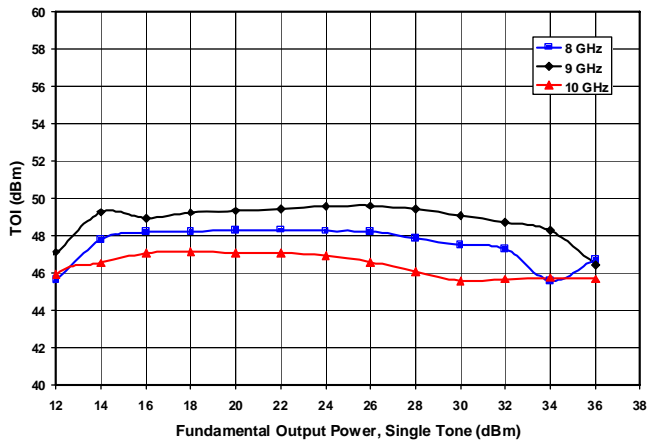


Figure 11. Third Order Intercept vs. Output Power and Frequency at 8V.

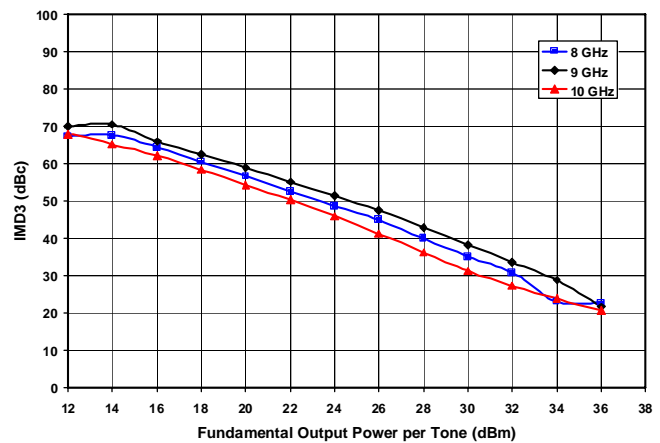


Figure 12. Third Order Intermod vs. Output Power and Frequency at 8V.

All Data is at 40°C MMIC base temperature, CW stimulus, unless otherwise noted.

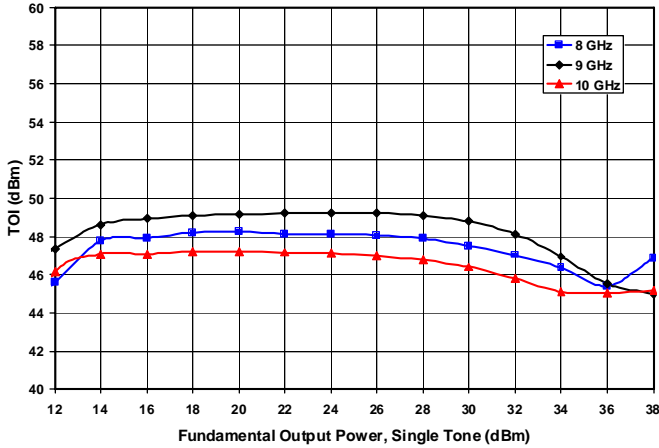


Figure 13. Third Order Intercept vs. Output Power and Frequency at 10V.

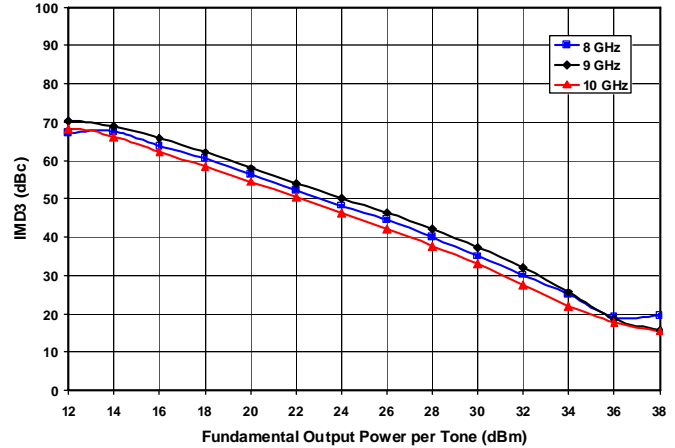


Figure 14. Third Order Intermod vs. Output Power and Frequency at 10V.

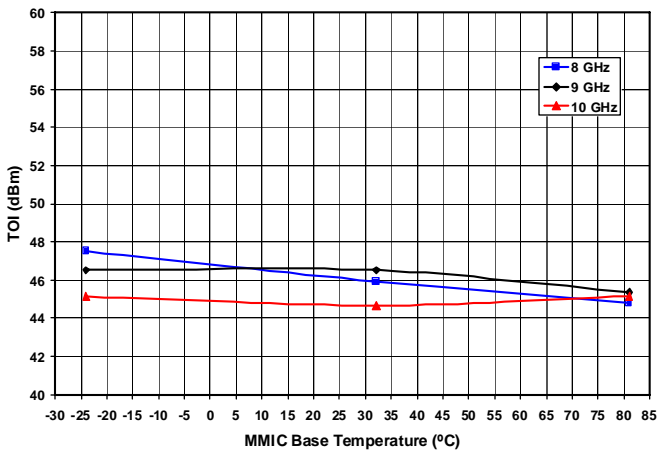


Figure 15. Third Order Intercept vs. Temperature and Frequency at 10V and $P_{out} = 39$ dBm DCL.

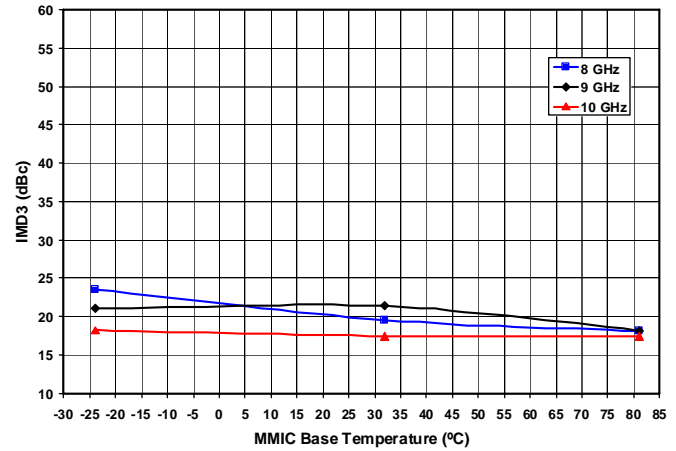


Figure 16. Third Order Intermod vs. Temperature and Frequency at 10V and $P_{out} = 39$ dBm DCL.

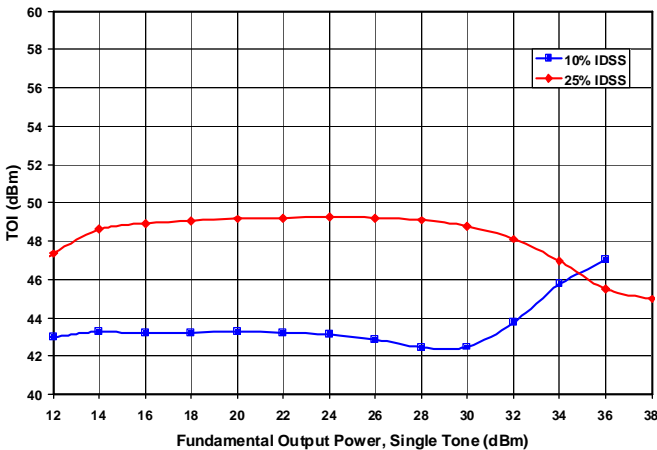


Figure 17. Third Order Intercept vs. Output Power and %IDSS at 10V and 9GHz.

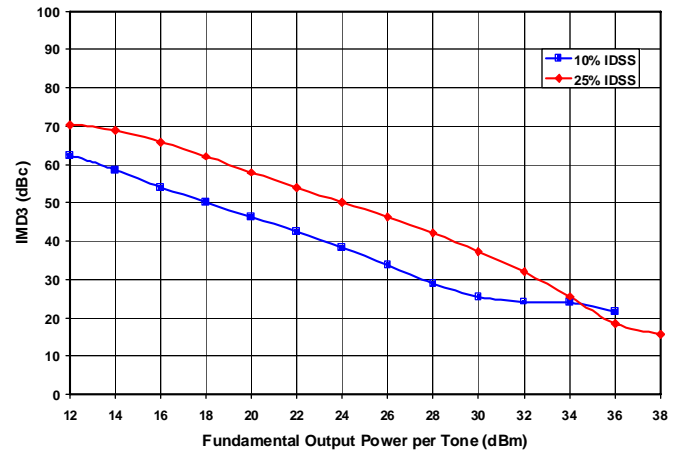


Figure 18. Third Order Intermod vs. Output Power and %IDSS at 10V and 9GHz.

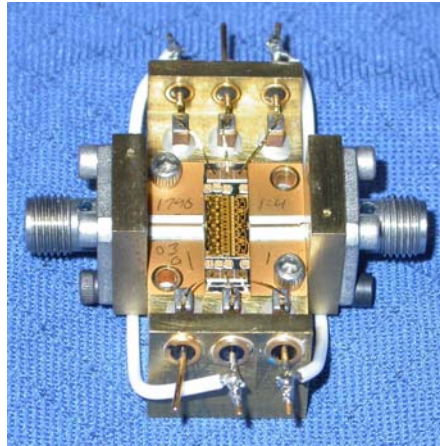
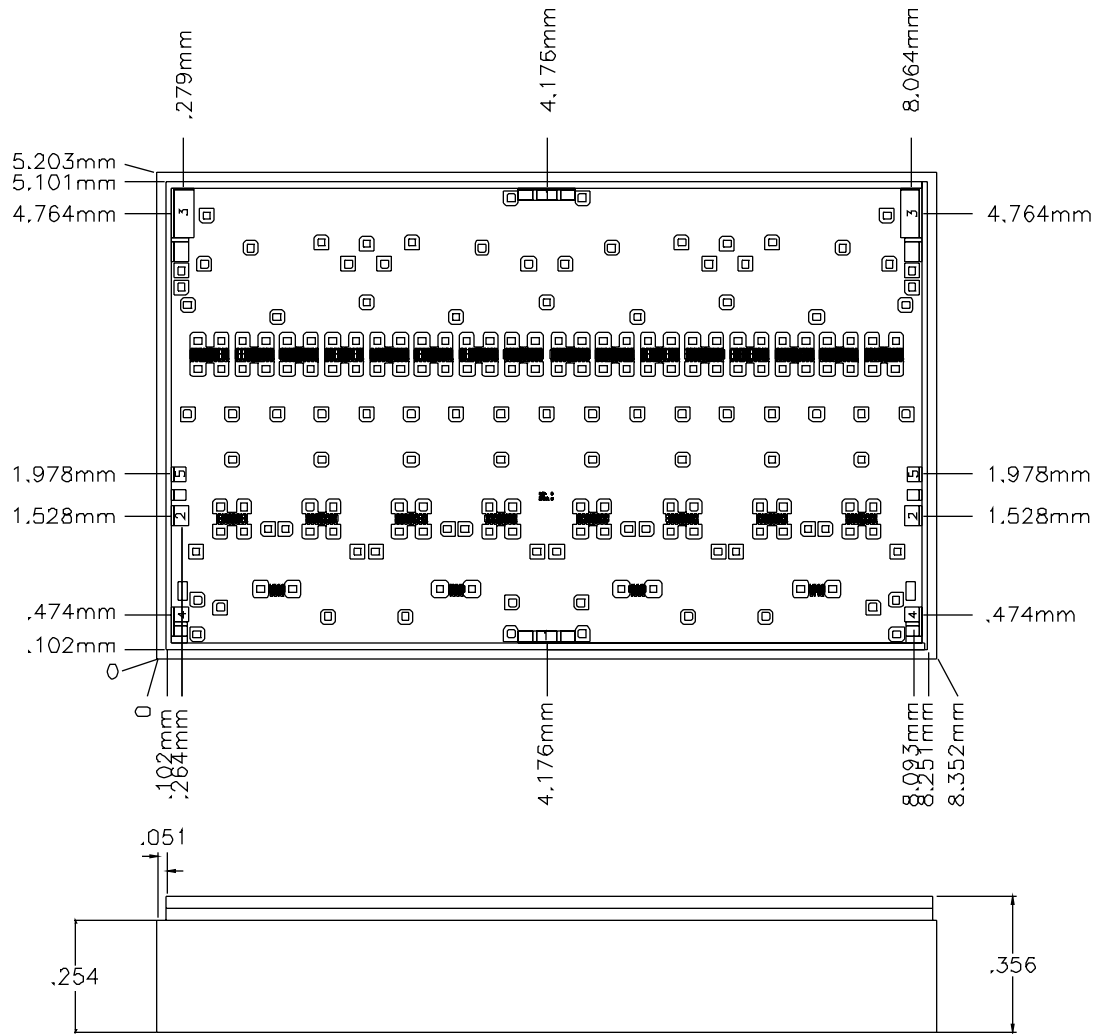


Figure 19. Fixture used to characterize MAAPGM0079-DIE under CW stimulus.

Mechanical Information



Chip edge to bond pad dimensions are shown to the center of the bond pad.

Figure 20. Die Layout

Bond Pad Dimensions

Pad	Pad No.	Size (µm)	Size (mils)
RF In and Out	1	100 x 200	4 x 8
DC Drain Supply Voltage $V_{D1,2}$	2	200 x 150	8 x 6
DC Drain Supply Voltage V_{D3}	3	500 x 200	20 x 8
DC Gate Supply Voltage $V_{G1,2}$	4	150 x 150	6 x 6
DC Gate Supply Voltage V_{G3}	5	150 x 125	6 x 5

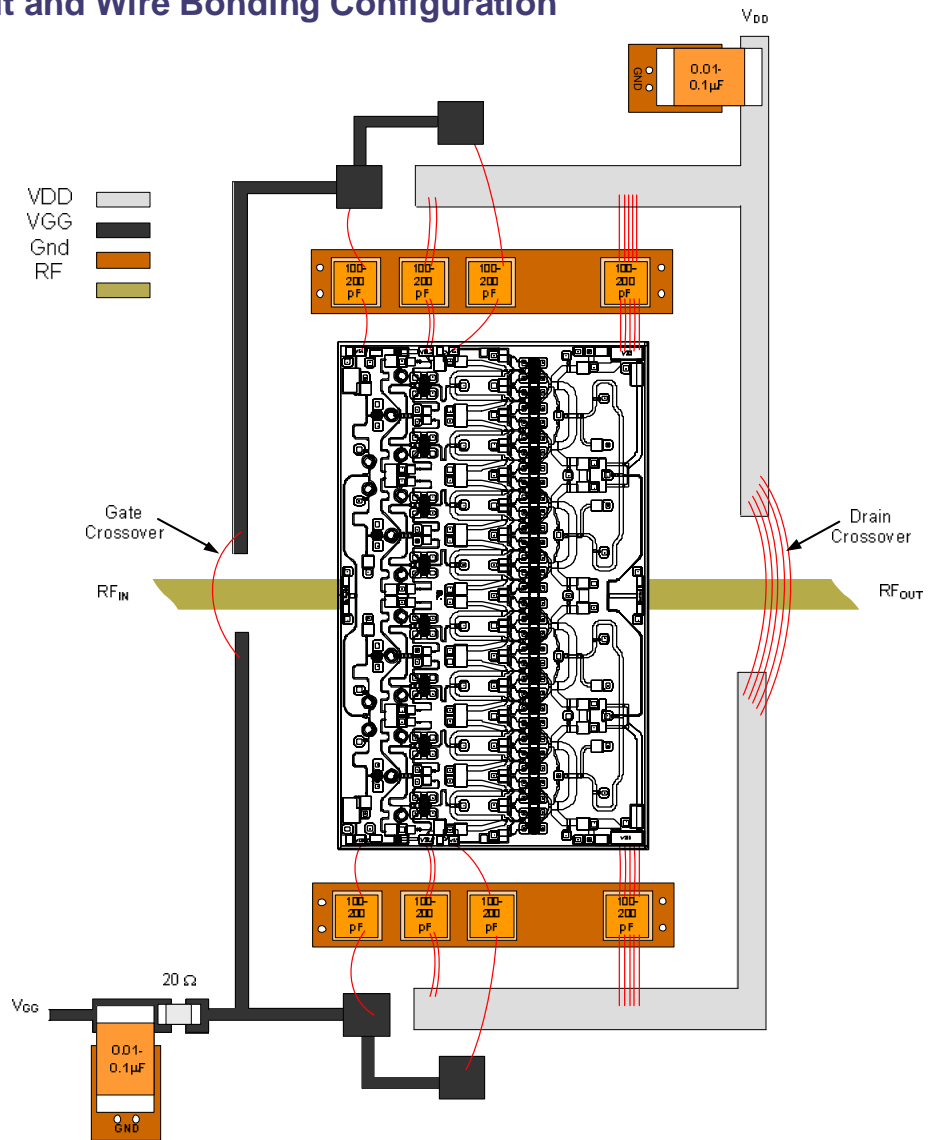
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Recommended Layout and Wire Bonding Configuration



In implementing the DC/ RF crossover shown, the following rules must applied.

1. the DC crossovers should approach and cross the RF trace at a 90 degree angle;
2. the printed DC traces that approach the RF line should be stopped 2 substrate heights from the RF line edge;
3. the rated current capability of the DC crossovers should be greater than the maximum current of the device; and
4. the wires or ribbons used to make the DC crossovers should clear the RF trace by ~ 1 substrate height.

Power Supply Sequencing:

Must apply negative bias to V_{GG} before applying positive bias to V_{DD} to prevent damage to amplifier.

Die Handling:

Refer to Application Note AN3016. All Application Notes may be accessed by going to <http://www.macom.com/Application%20Notes/index.htm>.

Next Level Assembly Instructions:

Pedestal Die Attach: The following paragraphs detail recommendations and instructions for the integration of the die on pedestal (IC assembly) and mating substrates to the next level assembly. These recommendations are summarized pictorially in Figure 20.

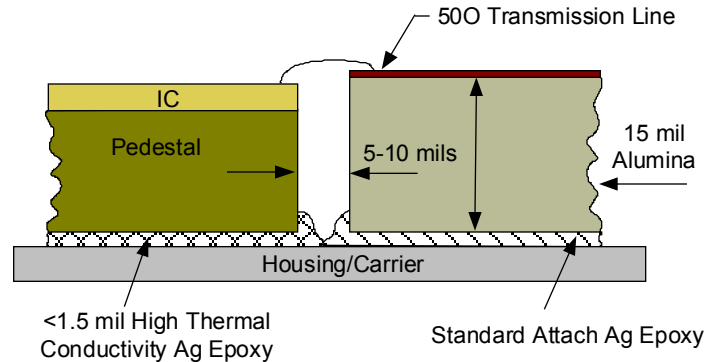


Figure 20. Cross-section of die-on-pedestal integration at next level assembly

To attach the die/pedestal assembly to the next level assembly, use a high thermal conductivity silver loaded epoxy. Two epoxies are recommended for this purpose, Diemat (www.diemat.com) PNs DM6030HK and DM4030LD with bulk thermal conductivities of 60 and 15 W/m-°C, respectively. Silver-filled epoxies with conductivities < 10 W/m-°C are not recommended for use in attaching these IC assemblies.

DM6030HK is recommended for use when the coefficient of thermal expansion (CTE) of the material to which the IC assembly is to be attached is similar to that of CuMo (CTE ~ 7ppm). A next level assembly attach material with a CTE range of 4-10ppm would be acceptable. DM4030LD is recommended when the CTE of the next level assembly material is significantly greater than CuMo, e.g, Copper and Aluminum with CTEs of 14 and 23 ppm, respectively.

Bondline thickness, the as-cured thickness of the silver epoxy layer between the IC assembly and next level assembly attach surface, is a critical parameter in terms of device performance and reliability. Bondline thickness should be maintained between 1 and 1.5 mils. A bondline thickness of < 1 mil reduces the sheer strength of the mechanical attach. Bondline thicknesses > 1.5 mils impacts in an incremental fashion the junction temperature of the IC and thereby the MTTF.

The pedestal thickness used in the IC assembly is set at 10 mils such that the final IC assembly thickness is ~ 14 mils making it approximately planar with a mating substrate of 15 mil alumina, a thickness commonly used through X-band. This surface planarity was an objective because it results in shorter RF bond wire lengths between the IC assembly RF I/O and the mating substrate transmission line. Long bond wires can shift the load impedance required for ideal power transfer. Shorter RF bond wires result in improved RF performance.

In any nominal microelectronic manufacturing environment, the process of silver epoxy attach of substrates and IC assemblies to the next level assembly can result in variable epoxy squeeze-out or run-out at the substrate or IC assembly peripheries. This variability, if not compensated for in the design of the overall assembly, can result in a high number of assembly failures due to epoxy wicking. This wicking process can occur when a mating substrate and IC assembly are placed too close to each other. To avoid this occurrence, a designed-in 5-10 mil spacing between the IC assembly and mating substrates is recommended.

Wirebonding: Bond @ 160°C using standard ball or thermal compression wedge bond techniques. For DC pad connections, use either ball or wedge bonds. For best RF performance, use wedge bonds of shortest length, although ball bonds are also acceptable.